



00862.022183

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
	:	Examiner: I. Soward
Haruhito ONO et al.	)	
	:	Group Art Unit: 2822
Application No.: 09/819,737	)	
	:	Confirmation No.: 4343
Filed: March 29, 2001	)	
	:	
For: ELECTROOPTIC SYSTEM ARRAY,	)	
CHARGED-PARTICLE BEAM	:	May 6, 2004
EXPOSURE APPARATUS USING THE	)	
SAME, AND DEVICE	:	
MANUFACTURING METHOD	)	

**Mail Stop Amendment**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application  
as follows: